## Point Autofocus Probe

## POINT AUTOFOCUS PROBE

 SURFACE TEXTURE MEASURING INSTRUMENTPF-60

Faster
Easier
More precise
\#\#itaka

## Measure large areas quickly

## Large measuring area / high precision measurement

The laser probe with a radius of $0.5 \mu \mathrm{~m}$ and the precision XY stage directly measure an area of several tens of millimeters down to the sub-micrometer level (measuring range: $\mathrm{XYZ}=60 \mathrm{~mm} \times 60 \mathrm{~mm} \times 10 \mathrm{~mm}$, scale resolution: $\mathrm{XY}=0.1 \mu \mathrm{~m}, \mathrm{Z}=0.01 \mu \mathrm{~m}$ )


## Fast 3D measurement

## 1hour 20 minutes (conventional instruments) <br> 6 minutes per 128000 points

Fast scanning autofocus (AF) function provides large measuring area and high precision measurement


Sinusoidal roughness NIST certified SRM2074 calibration standard



2D measurement: measuring time is only
15 sec. / 8000 points

## Higher precision/ easier operation

## Excellent angle tracking capability

The highly sensitive autofocus sensor captures low levels of light reflected from the surface of the sample and directly measures steep angles and step heights.


Maximum measurable angle : 87 degrees


## Measure visually!

High precision measurement with easy operations

The objective changer (with a slide mechanism) switches between a low power objective for observation and a high power objective for measurement in a single step operation


Monitor the sample while measuring


## ISO approved Mitaka measuring method

We proposed our measuring principle to the International Standards Organization (ISO) as a non-contact measuring method. Our principle has been included in ISO 25178-6:2010 - Classication of methods for areal surface texture - under the name "Point Autofocus Proling" (ISO 25178-605: Point autofocus probe).


## Measuring principle

## Overview

The PF-60 consists of an autofocus laser beam microscope (AF microscope) and a high precision XY scanning stage. The AF microscope measures height in the $Z$ axis and the $X Y$ stage moves the sample in order to obtain XYZ coordinate values for 2D and 3D measurements.

## Scanning XY stage

The PF-60 drives the high-precision XY stage to obtain the coordinate values in its full range of movement ( $60 \mathrm{~mm} \times 60 \mathrm{~mm}$ ). There is no need to stitch measured data since the PF-60 has no measuring limits (such as a restricted field of view) and hence provides high precision measurement of a large area.

## Point autofocus probe

The laser beam incorporated in the AF microscope passes through the objective (indicated by the red line in the above diagram) and forms a laser spot on the surface of the sample as a "probe" with a radius of $0.5 \mu \mathrm{~m}$.
The reflected laser beam from the sample surface passes through the objective again and forms an image on the autofocus sensor (AF sensor). The AF sensor detects the laser spot displacement in real time and adjusts the AF microscope back to the in-focus position (the laser spot forms its image at the center of the AF sensor).
standards for roughness measurement
Point autofocus profiling (PAP) has a high correlation with roughness standard materials for stylus instruments and obtains reliable data.


## Autofocus optical sytem cuts ghost and stray light

The autofocus optical system cuts out unnecessary light to achieve targetted measurement.


Transmissive surface


Secondary reection of a Vee-groove

## Surface texture measuring functions

## 2D roughness \& contour

$\mathrm{Ra}=0.104 \mathrm{Sm}=10(\mathrm{~m}) \quad$ Roughness standardPubert) Measured dataRa=0.101, $\mathrm{Sm}=10$ (m )
Scanning speed300 m/S


Measuring result for the contour standard


## Various auxiliary functions

## Image capture

The image capture function displays the scale and saves images within the measuring software environment. It facilitates positioning over the measuring area, makes it possible to observe the sample surface during measurement, and provides size measurement within the field of view.


## Mask measurement

Mask measurement provides three types of 3D measurement: inner circle measurement, outer circle measurement and doughnut measurement.
This function reduces total measuring and assessment time by selecting a restricted measuring area.


## Sufface topography \& aical roughness



## Temperature correction software

This software ensures that, even when the PF-60 is installed in a non-temperature-controlled room, it maintains measuring accuracy at the sub-micrometer level.


Patching increases vertical range virtually by combining sets of 3D data that are measured at different heights with respect to the same XY stage coordinate system.

Spherical surface


## Surface Texture Measurement comes in 3D

Microlens arrays (optical component)


Precision molding die


Wear volume of a brake pad (tribology)


Tooth ank roughness of a precision gear (precision processing)


Surface defect of a LED lens (optical component)


Tip of a turning tool


HDD head suspension (precision blanking)


Grinding work surface
(precision processing)


## Perfect solution for measuring all kinds of surface topography

High-density mounting board
(electronic component)


Microencoder (MEMS)


Flow marks (ow lines) of a molding


Fingerprint (medical \& cosmetics)


BGA(semiconductor)


Braille (welfare)


Human hair (cosmetics)


## 3D Surface Texture Analysis Software MitakaMap ST

Interactive and user-friendly software complete with powerful online help. Advanced analysis is carried out by applying straightforward operations to measurement data.


1 Minidocs
Automatic analysis by insertion of pre-defined sequences of analysis steps
iewer
Fast navigation to every page in the analysis report
Studies
Icons for analytical studies applicable to the selected data set

Online help
Detailed descriptions of all studies and operators
5 Document page Current page in the analysis report
Analysis workflow Tree view of all analysis steps in the report


Result: Roughness: $R \otimes .102, R z=0.331, R s m=10.0 m) \quad$ Waviness: $W z=0.04(1 \mathrm{~m})$

Standard parameter
(ISO 4278/JIS B 0601, ASME B46.1
Height(peak and valley
Rz, Ra, Rp, Rv, Rc, Rq,
Rsk, Rsq
Spacing:Rsm, Rdq
Material ratio: Rmr, Rdc
Peak:Ppc

- Peak:Ppc


## Profile analysis

Contour analysis
Automatic calculation of width, height, curvature and distance.
The tolerance limit function is a perfect solution for quality control of precision parts.

Vee-groove analysis


## Areal surface texture analysit

Parameters defined in ISO 25178 are pre-installed.

## Standard parameters

Height: Sz, Sa, Sp, SV, Sq, Ssk, Sku, ISO 4278-2, ASME B46.1, EUR15178N

- Flatness FLTt, FLTp, FLTv, FLTq (ISO 1278)



## MitakaMap ST Automatic Analysis Tools

Surface metrology reports include comprehensive analysis results

## Inspection report creation

Reports containing analytical studies are created frame by frame in an intuitive desktop publishing environment. Headers, company logos, etc. on a master page are repeated on all pages of a report.


## Supporting 10 languages

MitakaMap supports 10 languages, facilitating global cooperation.
[Supported language\$

| OJapanese | English French | German |
| :--- | :--- | :--- |
| Oltalian | Chinese OKorean | Spanish |
| OPolish | Brazilian Portuguese |  |

## MitakaMap XT Expert

MitakaMap XT is available as an upgrade to MitakaMap ST (standard software) and contains parameters required for R\&D and specialized applications. It also provides extended quantitative analysis of surface texture.


## Advanced Contour Module

Additional operators and studies for Contour Analysis (standard) and Advanced Contour Analysis (optional module) provide powerful dimensional and form deviation analysis


## Motifs Analysis

Dividing surface asperity into ridge and course lines in order to extract local peaks and pits for detailed surface observations



| Mechanical Section |  |  |  |  | Software |
| :---: | :---: | :---: | :---: | :---: | :---: |
| Axes | X axis | Y axis | AF (Z1) axis (for measurement) | Z2 axis (for positioning) | 2D/3D surface texture measuring software <br> - Profile <br> - Areal (index/ scanning mode) 3D surface texture analysis software (MitakaMap ST) |
| Measuring range | 60 mm | 60 mm | 10 mm | 60 mm |  |
| Positioning resolution | $0.1 \mu \mathrm{~m}$ | $0.1 \mu \mathrm{~m}$ | $0.01 \mu \mathrm{~m}$ | $0.1 \mu \mathrm{~m}$ |  |
| Scale | Glass Scale | Glass Scale | Glass Scale | Pulse |  |
| Accuracy (L=length in mm ) | $(2+4 \mathrm{~L} / 1000) \mu \mathrm{m}$ | $(2+4 \mathrm{~L} / 1000) \mu \mathrm{m}$ | (0.3+0.5L/10) $\mu \mathrm{m}$ | - | - Profile surface analysis texture analysis (ISO 4287) roughness / waviness / primary profile height, width, peak, material ratio parameters |
| Autofocus optical system | Repeatability | $\sigma=0.03 \mu \mathrm{~m}$ (at mirror (specimen) surface) |  |  | ■ Areal surface texture analysis (ISO 25178) Areal height parameters |
|  | Focus area | $\phi 1 \mu \mathrm{~m}$ (with 100X objective) |  |  |  |
|  | Laser | Semiconductor laser (0/p: 1 mW Max $\lambda$ : 635 nm class 2 ) |  |  |  |
|  | Objective for measurement | 100 X (WD=3.4mm NA $=0.8$ ) obervation mag : approx.1100X (9-in monitor) |  |  | $\square$ Form removal <br> $\square$ Morphological filters $\square$ Abbott Curve |
|  | Objective for positioning | 5 X (slide mechanism) [field of view] |  |  | - Distance, Step-height analysis <br> Volume of holes and peaks |
|  | Epi-illumination | Köhler illumination (light source: white LED ) |  |  | Minidocs ■ lllustrations |
| Other | $\begin{aligned} & \hline \text { Dimensions of } \\ & \text { XY stage } \\ & \hline \end{aligned}$ | $210 \times 210 \mathrm{~mm}$ |  |  | Image Capture (Mitaka Veiwer) <br> ■ reticle/scale display $\quad$ saving images Data export Excel-compatible ASCII text files |
|  | Max sample size | 70 mm (up to 100 mm in height with AF unit) |  |  |  |
|  | Max sample weight | 4kg |  |  |  |
|  | $\begin{aligned} & \text { Instrument size } \\ & (W \times D \times H) \end{aligned}$ | Mechanical section: $400 \times 400 \times 450 \mathrm{~mm}$ |  |  | Optional software |
|  | Vibration isolator | 3 point supporting pad (proper oscillation lateral: 3.5 vertical: 4 Hz ) |  |  | Advanced Contour ModuleMotifs Analysis OStatisticsUpgrade to MitakaMap XT |
|  | Instrument weight | 31 kg |  |  |  |
|  |  | Controller |  |  |  |
| User interface |  | Personal computer (OS: Windows) |  |  | Other options |
| Drive control |  | 4-axial controller (MSCN-4N) |  |  | 50X objective ( $\mathrm{WD}=10.6 \mathrm{~mm} \mathrm{NA}=0.5$ )High NA100 X objective (WD $=0.35 \mathrm{~mm} N A=0.95$ ) |
| Power consumption (total) |  | 250W (100V2.5A) |  |  |  |

## Product Portfolio

Mitaka Kohki provides a range of point autofocus probe measuring instruments including NH-Series, non-contact 3D measuring instruments, and MLP-2, a 360 degree form measuring instrument. The NH-Series is a perfect solution for measuring dimensions and surface texture and the MLP-2 is ideal for rotative measurement. Mitaka point autofocus systems are widely installed in ultraprecision machining manufacturers, electronic components, optical components and other industrial fields.


Model: PF-150 (6-inch scanning model)
Measuring range: $\mathrm{XYZ}=150 \mathrm{~mm} X 150 \mathrm{~mm} \times 10 \mathrm{~mm}$ Scale resolution: $\mathrm{XYZ}=0.1 \mu \mathrm{~m}, 0.1 \mu \mathrm{~m}, 0.01 \mu \mathrm{~m}$ Applications: grinding wheels, optical components, molds and dies, etc.


Model: NH-3SP (Super precision model)
Measuring range: $X Y Z=150 \mathrm{~mm} X 150 \mathrm{~mm} X 10 \mathrm{~mm}$
Scale resolution: $\mathrm{XYZ}=0.01 \mu \mathrm{~m}, 0.01 \mu \mathrm{~m}, 0.001 \mu \mathrm{~m}$
Applications: aspherical lenses, semiconductors, precision molds, etc.


Measuring range: $\mathrm{XYZ}=600 \mathrm{~mm} \times 600 \mathrm{~mm} \times 10 \mathrm{~mm}$ Scale resolution: $\mathrm{XYZ}=0.1 \mu \mathrm{~m}, 0.1 \mu \mathrm{~m}, 0.01 \mu \mathrm{~m}$ Applications: large optical components, large molds and dies, LCD panels, etc.


Model: MLP-2 (360-degree measurement model) Measuring range: $X Y Z=120 \mathrm{~mm} \times 90 \mathrm{~mm} \times 130 \mathrm{~mm}$

$$
\mathrm{AF}(\mathrm{R})=40 \mathrm{~mm}, \mathrm{AZ}(\theta)=360^{\circ}
$$

Scale resolution: $X Y Z=0.1 \mu \mathrm{~m}, 0.1 \mu \mathrm{~m}, 0.1 \mu \mathrm{~m}$

$$
\mathrm{AF}(\mathrm{R})=0.01 \mu \mathrm{~m}, \mathrm{AZ}(\theta)=0.001^{\circ}
$$

Applications: precision gears, endmills, punches, molds for connectors, etc.

## Witaka

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